

OPEN Strain-induced perpendicular magnetic anisotropy and Gilbert damping of Tm₃Fe₅O₁₂ thin films

Oana Ciubotariu1*, Anna Semisalova2,3, Kilian Lenz2 & Manfred Albrecht1

In the attempt of implementing iron garnets with perpendicular magnetic anisotropy (PMA) in spintronics, the attention turned towards strain-grown iron garnets. One candidate is Tm₃Fe₅O₁₂ (TmIG) which possesses an out-of-plane magnetic easy axis when grown under tensile strain. In this study, the effect of film thickness on the structural and magnetic properties of TmIG films including magnetic anisotropy, saturation magnetization, and Gilbert damping is investigated. TmIG films with thicknesses between 20 and 300 nm are epitaxially grown by pulsed laser deposition on substituted-Gd₃Ga₅O₁₂(111) substrates. Structural characterization shows that films thinner than 200 nm show in-plane tensile strain, thus exhibiting PMA due to strain-induced magnetoelastic anisotropy. However, with increasing film thickness a relaxation of the unit cell is observed resulting in the rotation of the magnetic easy axis towards the sample plane due to the dominant shape anisotropy. Furthermore, the Gilbert damping parameter is found to be in the range of 0.02 ± 0.005 .

Yttrium iron garnet (Y₃Fe₅O₁₂, YIG) is an insulating ferrimagnet with an extremely low Gilbert damping parameter in the order of 10^{-4} 1,2 making it the ideal choice for spin transport studies, including inverse spin Hall effect (ISHE)³, spin Seebeck effect⁴, spin wave propagation⁵, and spin colossal magnetoresistance⁶. YIG layers exhibiting a cubic structure (space group Ia-3d) with a lattice parameter of a = 12.376 Å are commonly grown on $\mathrm{Gd}_3\mathrm{Ga}_5\mathrm{O}_{12}$ (GGG, a = 12.383 Å) substrates due to the small lattice mismatch ($\Delta = 100(a_{\text{sub}} - a_{\text{film}})/a_{\text{sub}} = 0.05\%$) by pulsed laser deposition (PLD)¹⁻⁶ or sputtering⁷. In thin film form, the magnetic shape anisotropy overcomes the weak magnetocrystalline anisotropy⁸, thus revealing an in-plane (ip) magnetic easy axis. Nevertheless, tailoring the magnetic easy axis direction would open new potential applications in the field of magnon spintronics9. One method for achieving perpendicular magnetic anisotropy (PMA) is by induced strain giving rise to magnetoelastic anisotropy. According to refs. 10,11 , iron garnets with a negative (positive) magnetostriction constant (λ_{111}) can have an out-of-plane (oop) easy axis of magnetization when grown under in-plane tensile (compressive) strain. Several approaches have been proposed to achieve for YIG layers an oop easy axis of magnetization, including the variation of oxygen pressure during growth and substrate type¹². However, in these studies no PMA could be observed for YIG films grown on GGG(111) and substituted-GGG (sGGG, $a = 12.505 \,\text{Å}$) (111) substrates. In contrast, Krockenberger et al. observed for 100 nm thick YIG films grown on GGG(111) substrates weak PMA associated with a slight elongation of the unit cell along the surface normal¹³. Additionally, Popova et al. reported for 10 nm thick polycrystalline YIG films deposited on quartz substrates by PLD the presence of weak PMA with low remanent magnetization 14,15. Recently, tensile strain-induced magnetoelastic anisotropy was observed for YIG films grown on $(Gd_{0.63}Y_{2.37})(Sc_2Ga_3)O_{12}$ ($\Delta=1.04\%$) and $Gd_3(Sc_2Ga_3)O_{12}$ ($\Delta=1.56\%$) substrates leading to an oop magnetic easy axis for film thicknesses below 15 nm¹⁶. Additionally, stress-engineered 20-40 nm thick YIG films sandwiched between a buffer and a cover layer revealed a suppressed in-plane strain relaxation, thus, allowing the presence of PMA in the order of 12 kJ/m³ ¹⁷. Furthermore, adding third elements can induce sufficient in-plane tensile strain to the unit cell resulting in strain-induced PMA as demonstrated for Bi-doped YIG films on sGGG(111) with little impact on the Gilbert damping parameter ($\alpha = 3 \times 10^{-4}$)¹⁸.

In the attempt of improving PMA for larger film thicknesses, the attention turned to other rare earth-based iron garnets while trying to maintain a low Gilbert damping parameter^{12,19,20}. A promising candidate is Tm₃Fe₅O₁₂ (TmIG, a = 12.323 Å). Due to the negative magnetostriction constant of $\lambda_{111} = -5.2 \times 10^{-6}$ 8, possible substrate

¹Institute of Physics, University of Augsburg, Universitätsstraße 1, 86135, Augsburg, Germany. ²Institute of Ion Beam Physics and Materials Research, Helmholtz-Zentrum Dresden-Rossendorf, Bautzner Landstraße 400, 01328, Dresden, Germany. ³Present address: Faculty of Physics, University of Duisburg-Essen, Lotharstraße 1, 47057, Duisburg, Germany. *email: oana-tereza.ciubotariu@physik.uni-augsburg.de

choices for the growth of TmIG films under tensile strain are GGG (Δ = 0.49%) and sGGG (Δ = 1.45%) substrates. Since for most garnets the [111] direction is the crystallographic easy axis of magnetization⁸, (111)-oriented substrates are commonly chosen. Tang *et al.* observed for 10 nm thick TmIG films an oop easy axis of magnetization when grown on sGGG(111) substrates while 10 nm thick TmIG layers on GGG(111) substrates showed an ip easy axis of magnetization, suggesting an insufficient tensile strain for the latter case²¹. A similar result was recently found by Ahmed *et al.* for extremely thin layers (<2 nm)²². However, Kubota *et al.* reported the growth of epitaxial TmIG films (46–350 nm) on GGG(111) by PLD under tensile strain revealing PMA¹⁹. Films thinner than 30 nm were observed to have similar magnetic properties with a magnetoelastic anisotropy of 17.5 kJ/m³ ^{23,24}. In a recent study, off-axis sputter-deposited TmIG films on GGG(111) in the thickness range of 10–30 nm showed PMA and low Gilbert damping of α = 0.0133²⁵, still being two orders of magnitude higher than for YIG films. Hence, subtle differences regarding growth and strain conditions obviously influence the overall magnetic properties of rare earth-based iron garnet films.

The presented study is focusing on the evolution of the structural and magnetic properties of TmIG thin films with film thickness. Films were grown epitaxially by PLD at 615 °C on sGGG(111), allowing for a higher in-plane tensile strain than GGG(111) substrates. Furthermore, the Gilbert damping parameter was determined.

Methods

 $Tm_3Fe_5O_{12}$ films were grown by PLD from a commercially available polycrystalline $Tm_3Fe_5O_{12}$ target (G-Materials GmbH) with a purity of 99.99%. Prior to deposition, the target was cleaned under vacuum (10^{-6} mbar) with 10,000 laser pulses at an energy of 300 mJ (pulse length: 20 ns, wavelength: 248 nm). In the PLD chamber, the substrate was placed approximately 4 cm in front of the target and the temperature was monitored via a thermocouple placed in the sample holder. For a good thermal contact with the sample holder, the back side and the edges of the substrates were covered with silver paste.

In order to identify the growth conditions of stoichiometric films, TmIG films (110-160 nm) were prepared on silicon substrates at 650 °C while the oxygen pressure (pO₂) was varied between 0.04 and 0.4 mbar. The films stoichiometry and the deposition rates were analyzed by Rutherford backscattering spectrometry (RBS) using the SIMNRA program²⁶. For this study, we have chosen silicon instead of sGGG substrates in order to extract reliable values for the composition and thickness due to the small atomic mass difference between Fe and Ga, and Tm and Gd atoms resulting in an overlap of the corresponding peaks in the RBS spectra. All spectra were acquired for an incident He²⁺ ion energy of 3.0 MeV. The RBS analysis showed that for $pO_2 = 0.04$ mbar the Tm/Fe ratio is close to the stoichiometric value of 0.6. With increasing pO_2 , the films become Tm-rich and for $pO_2 = 0.4$ mbar a Tm/ Fe ratio as high as 0.7 was measured. Please note that the reported values for the oxygen pressure typically used for TmIG growth are in a higher range of 0.26-1.06 mbar 19,23,24, but this depends strongly on target stoichiometry. Further studies on TmIG(70-100 nm)/sGGG(111) regarding substrate temperature, laser pulse energy, and pulse rate using an oxygen pressure of 0.04 mbar revealed an optimum at 615 °C, 300 mJ, and 2 Hz, respectively. Under these conditions stoichiometric TmIG films with thicknesses between 20 and 300 nm were grown epitaxially by PLD on sGGG(111) substrates (at a rate of 0.03 nm/s). After deposition, the samples were cooled with a rate of -13 °C/min although in literature smaller values are reported for iron garnets 24,27 . The impact of the cooling rate was investigated on 70 nm thick TmIG films cooled with different rates between -2 °C/min and -13 °C/ min. However, only a minor impact of the cooling rate on the structural and magnetic properties was observed

The surface morphology of the films was investigated by atomic force microscopy (AFM) and the structural characterization was carried out by x-ray diffraction (XRD) whereas the magnetic properties were investigated by superconducting quantum interference device – vibrating sample magnetometry (SQUID–VSM). Before the magnetic characterization, the sample edges were cut using a diamond saw and the backside was polished using sand paper in order to remove the silver paste. Furthermore, a correction of the magnetic field values was required due to the remanent magnetic field (approximately 30 Oe) of the superconducting coils. For this procedure a paramagnetic palladium reference sample was measured following the same sequence as the one carried out for the TmIG samples. For a paramagnetic sample, the field dependence of the magnetization is a straight line passing through zero. As a result of the trapped magnetic field in the superconducting material, an open hysteresis loop is observed for the reference sample. By applying a fitting routine for correcting the magnetic field values, a straight line passing through zero is restored. Ferromagnetic resonance (FMR) measurements were performed to extract the magnetic anisotropy and the damping parameter using a Vector Network Analyzer (VNA) setup. An Agilent VNA was used to excite the ferromagnetic resonance in the thin film placed on a coplanar waveguide in the range of 1–40 GHz. The complex microwave scattering parameter S_{21} , i.e. the transmission signal between the VNA ports, was recorded as the FMR signal while the external magnetic field was swept at a fixed microwave frequency.

Results and Discussions

Figure 1 shows XRD θ –2 θ scans measured for all samples around the sGGG (444) reflection. The diffraction pattern of a bare substrate is displayed for comparison, revealing a splitting of the main (444) reflection due to contributions from the Cu K α ₁, Cu K α ₂, and Cu K α _{3,4} radiations^{28,29}, which are sometimes misinterpreted in the literature³⁰.

From the XRD patterns, a strong influence of the TmIG film thickness on the crystalline structure is apparent. All films with thicknesses below 200 nm have the (444) diffraction peak at 2θ angles larger than for bulk TmIG³¹, which indicates a compressed lattice in growth direction. This compression should result in an expanded lattice in the film plane inducing tensile strain, the required condition for obtaining an out-of-plane magnetoelastic anisotropy contribution. The largest distortion is measured for the thinnest films of 20 and 50 nm. With increasing film thickness, the (444) peak shifts towards smaller angles indicating a structural relaxation towards the bulk

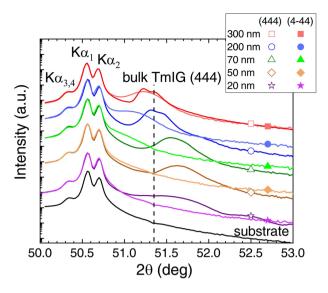


Figure 1. XRD θ -2 θ scans of the (444) and (4-44) planes of TmIG/sGGG(111) samples for various film thicknesses and of a bare substrate. The position of bulk TmIG (444) reflection is marked with a vertical line.

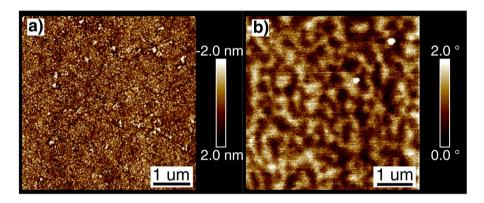


Figure 2. (a) Surface topography and (b) magnetic domain structure of a 70 nm thick TmIG film grown on sGGG(111). Please note that the images were taken at different sample areas.

structure. Please note that a slight off-stoichiometry can explain the difference between the (444) peak position of bulk and $300\,\mathrm{nm}$ thick film.

For a cubic system (e.g. sGGG and TmIG), the <111> directions are equivalent and, according to Bragg's law, the corresponding diffraction planes have the same diffraction angle. Therefore, the distortion of the unit cell was investigated from the position of the (4–44) reflection. To access the (4–44) diffraction plane, each sample was tilted to $\chi = 70.53^{\circ}$. The corresponding scans are included in Fig. 1. For the sGGG substrate, due to the cubic crystal structure, the (444) and (4–44) reflections overlap perfectly. In contrast, pronounced differences are visible between the (444) and (4–44) reflections of the films clearly confirming the strong lattice distortion. For the 20 and 50 nm thick films, the (4–44) diffraction peak is hardly visible as a shoulder on the right side of the substrate peak. With increasing film thickness, the (4–44) diffraction peak shifts towards higher angles approaching the (444) reflection which indicates the relaxation into the cubic structure.

The surface morphology of the 70 nm thick TmIG film was investigated by AFM showing a root mean square (rms) roughness of about 0.8 nm extracted from the topographic image presented in Fig. 2(a). Throughout the series, all film samples exhibit a smooth and continuous surface with a rather low rms roughness of less than 1 nm.

It is expected that the observed structural changes will strongly influence the magnetic properties. In order to possess an out-of-plane magnetic easy axis, the induced magnetoelastic anisotropy has to overcome the magnetic shape anisotropy of the film (the magnetocrystalline contribution is discussed below). Figure 3 displays the normalized M-H hysteresis loops measured with the magnetic field applied in the oop and ip direction after subtraction of the substrate paramagnetic contribution.

The 50 nm thick TmIG film exhibits a rather square hysteresis loop in oop direction with a coercivity of about 18.3 kA/m (230 Oe). For the ip direction, a small hysteresis with a lower coercivity of 4.7 kA/m (60 Oe) and a linearly increasing magnetization towards saturation is obtained, confirming PMA with an easy axis along the surface normal. Thus, for this film thickness, the magnetoelastic anisotropy is dominant. A similar behavior is expected

Figure 3. Normalized *M*–*H* hysteresis loops measured in (**a**) out-of-plane and (**b**) in-plane geometry. The paramagnetic substrate contribution was subtracted from the measured data. Inset displays the polar MOKE loop measured for the 20 nm thick film.

for the 20 nm thick TmIG film. However, in case of weak magnetic film signals, the hysteresis loops become noisy, in particular at higher fields, after removing the substrate contribution (see Fig. 3 for 20 and 50 nm thick films). Therefore, an additional polar magneto-optical Kerr effect (MOKE) hysteresis loop was measured using a blue laser source (λ = 405 nm) and it is displayed in the inset of Fig. 3(a). The MOKE loop revealed a similar shape as observed by SQUID–VSM and confirmed the oop easy axis of magnetization with a rather low coercivity of about 2.95 kA/m (37 Oe). With increasing film thickness, the magnetic easy axis rotates towards the sample plane due to the loss in magnetoelastic anisotropy and competing contribution of the magnetic shape anisotropy.

The saturation magnetization (M_S) in dependence on the TmIG film thickness is shown in Fig. 4(a). The obtained M_S values of about 90 kA/m (90 emu/cm³) remain almost constant within the experimental error, which is smaller than for bulk TmIG (110 kA/m) but in good agreement with values reported by other groups^{23–25,32}.

The values of the effective magnetic anisotropy $K_{\rm eff}$ are summarized in Fig. 4(b). $K_{\rm eff}$ was estimated from the area enclosed between the out-of-plane and in-plane loops in one quadrant of the M-H loops and contains both perpendicular $K_{\rm u}$ and shape $K_{\rm s}$ ($K_{\rm s}=-1/2\mu_0M_{\rm S}^2$) anisotropies.

With the values of $K_{\rm eff}$ and $M_{\rm S}$, the perpendicular magnetic anisotropy energy density $K_{\rm u} = K_{\rm eff} - K_{\rm s}$ (filled red circles in Fig. 4(b)) was calculated to be around 6–10 kJ/m³ (60–100 kerg/cm³) for films thicknesses up to 70 nm. With increasing film thickness, the $K_{\rm u}$ values get reduced and eventually the magnetization rotates in the film plane as indicated by the sign change of $K_{\rm eff}$.

As mentioned above, <111> are the crystallographic easy axes. Therefore, the two contributions to the perpendicular magnetic anisotropy $K_{\rm u}$ (also often denoted as $K_{2\perp}$) are the magnetocrystalline anisotropy $K_{\rm l}$ and the magnetoelastic anisotropy $K_{\rm o}$ induced by tensile strain. For bulk TmIG, the first order cubic anisotropy constant $K_{\rm l}$ (often denoted as $K_{\rm d}$) is in the range of $-1.1\,{\rm kJ/m^3} < K_{\rm l} < -0.58\,{\rm kJ/m^3}$ and it is often neglected. Based on ref. ³³, the strain-induced magnetoelastic anisotropy $K_{\rm o}$ can be estimated using the formula

$$K_{\sigma} = -\frac{3}{2} \frac{Y}{1+\mu} \lambda_{111} \frac{d_{\text{bulk}}^{444} - d_{\text{film}}^{444}}{d_{\text{bulk}}^{444}}$$

where $\lambda_{111} = -5.2 \times 10^{-6}$ is the magnetostriction constant in the [111] direction. Instead of the Young's modulus Y and Poisson ratio μ of TmIG, the values of $Y = 2 \times 10^8$ kJ/m³ and $\mu = 0.29$ of YIG were used³³. The film interplanar distance $d_{\rm film}^{444}$ was calculated using Bragg's law and the film diffraction angle extracted from fittings of the XRD patterns. Considering that the TmIG films converge towards an oop lattice constant larger than of stoichiometric bulk TmIG (see Fig. 1), the interplanar distance $d_{\rm bulk}^{444}$ of the structure towards which the films converge was used for the calculation of K_{σ} . For the 50 nm thick film, K_{σ} was found to be 8.6 ± 0.7 kJ/m³. The value is close to $K_{\rm u}$ confirming the small magnetocrystalline contribution. As expected from the structural relaxation, K_{σ} strongly decreases with thickness reaching the smallest value of 0.6 ± 0.7 kJ/m³ for the 300 nm thick film. It should be noted that the strain values, which were extracted from the XRD data, are averaged film values. However, it is expected that the relaxation develops gradually along the growth direction rather than the films exhibiting a uniform strain profile, thus leading in turn to thickness-dependent magnetic anisotropies.

Magnetic force microscopy (MFM) was used to image the domain structure of the 70 nm thick film after demagnetization. A typical domain pattern with up and down magnetized domains in the size range of about 300 nm is shown in Fig. 2(b), confirming as well the presence of PMA.

In order to confirm the obtained values of the perpendicular magnetic anisotropy of TmIG films, a ferromagnetic resonance study was performed. The analysis of FMR data was done using the Smit-Beljers approach to derive the resonance conditions from the free energy F^{34-36} :

$$\left(\frac{\omega}{\gamma}\right)^2 = \frac{1}{(M\sin\theta)^2} \left(F_{\theta\theta}F_{\varphi\varphi} - F_{\theta\varphi}^2\right). \tag{1}$$

where

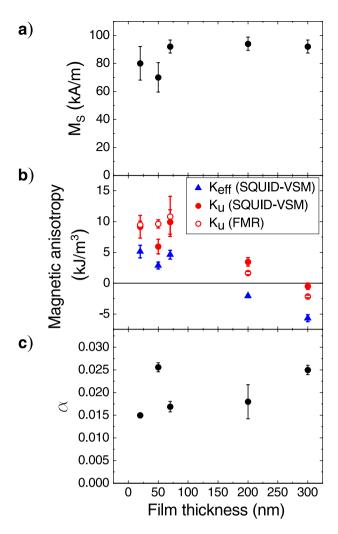


Figure 4. Dependence of (**a**) saturation magnetization, (**b**) magnetic anisotropy, and (**c**) Gilbert damping parameter on TmIG film thickness.

$$F = \frac{1}{2}\mu_0 M_{\rm S}^2 \cos^2 \theta - K_{\rm u} \cos^2 \theta - \mu_0 MH(\cos \theta \, \cos \theta_{\rm H} + \, \cos(\varphi - \varphi_{\rm H}) \sin \theta \, \sin \theta_{\rm H}).$$

Here, the polar (with respect to film normal) and azimuthal in-plane angles of magnetization M and applied field H are marked as (θ,φ) and $(\theta_{\rm H},\varphi_{\rm H})$, respectively. Note that the film normal is along the [111] crystallographic direction. The FMR spectra were recorded for each sample in the frequency range from 1 to 40 GHz for the in-plane and out-of-plane direction of the magnetic field. In addition, the polar and azimuthal angular dependencies of the resonance field were measured as well to extract the perpendicular magnetic anisotropy and to look for any cubic magnetocrystalline anisotropy contribution, respectively. To determine the resonance field $H_{\rm res}$ and resonance peak-to-peak linewidth $\Delta H_{\rm pp}$, the spectra were fitted using a complex Lorentzian function. Equation (1) was solved numerically at each frequency and $(\theta_{\rm H},\varphi_{\rm H})$ angles in order to fit the evaluated $H_{\rm res}$ values, herewith $\mu_0 M_{\rm S} - 2 K_{\rm u}/M_{\rm S} \equiv \mu_0 M_{\rm eff}$ was used as a fitting parameter. There are special cases for $\theta_{\rm H} = 0^{\rm o}$ and $\theta_{\rm H} = 90^{\rm o}$, where Eq. (1) can be solved analytically leading to the so-called Kittel formulae for resonance conditions (assuming no cubic anisotropy):

$$\frac{\omega}{\gamma} = \mu_0 H_{res,\perp} - \left(\mu_0 M_{\rm S} - \frac{2K_{
m u}}{M_{
m S}}\right), \; \theta_H = 0^{\circ}.$$

$$\left(\frac{\omega}{\gamma}\right)^2 = \mu_0 H_{\rm res,\parallel} \times \left(\mu_0 H_{\rm res,\parallel} + \mu_0 M_{\rm S} - \frac{2K_{\rm u}}{M_{\rm S}}\right)\!, \ \theta_H = 90^\circ. \label{eq:delta_H}$$

with $\gamma = g\mu_B/\hbar$, where g is the Landé factor. Thus, FMR is a direct method to calculate $K_{\rm u}$ using the $M_{\rm S}$ value from SQUID–VSM measurements³⁷.

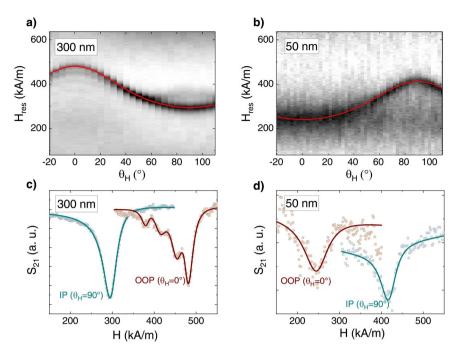


Figure 5. Polar angular dependence of the resonance field $H_{\rm res}$ at 10 GHz for TmIG films of (a) 300 nm and (b) 50 nm thickness, showing an in-plane and out-of-plane easy axis of magnetization, respectively. The red curves are fits according to Eq. (1). Experimental (open symbols) and fitted (solid line) FMR spectra of (c) 300 nm and (d) 50 nm thick TmIG films, respectively, measured in in-plane ($\theta_{\rm H} = 90^{\circ}$) and out-of-plane ($\theta_{\rm H} = 0^{\circ}$) applied magnetic field. The FMR signal was corrected for background sGGG contribution. For the 300 nm thick film, spin wave modes can be resolved when the magnetic field is applied perpendicular to the film surface.

Figure 5(a,b) shows the detailed polar angular dependencies for TmIG films of 300 nm and 50 nm thickness, demonstrating the opposite behaviour of resonance field with angle $\theta_{\rm H}$. The field-swept FMR scans are arranged along the y-axis as 2D color plot where the intensity of the FMR signal is marked by color. The individual FMR spectra at $\theta_H = 0^\circ$ and $\theta_H = 90^\circ$ for both films are illustrated by empty symbols in Fig. 5(c,d), while the solid curves represent fits to the experimental data. The background sGGG spectrum was carefully evaluated and subtracted from the presented curves. For the 300 nm thick film, the highest resonance field is observed at $\theta_{\rm H} = 0^{\circ}$ which is the direction of the magnetic hard axis. Additionally, in the oop direction ($\theta_H = 0^\circ$) spin waves up to the 4th mode can be observed on the left side from the main mode. A similar dependence was found for the 200 nm thick TmIG film. In contrast, for the 50 nm thick film the resonance field in $\theta_{\rm H} = 0^{\circ}$ direction is the lowest, implying that the easy axis is normal to the film plane. The films of 20 and 70 nm thickness showed similar behaviour. The strong contribution of perpendicular magnetic anisotropy can be clearly concluded for those films. The derived values of K_u from FMR data analysis are included in Fig. 4(b) by empty red circles. The difference between the K_u values extracted from FMR and SQUID-VSM data could be explained by the calculating method of K_{11} from the hysteresis loops. As mentioned above, $K_{\rm u}$ is given by the area enclosed between the oop and ip curves in one quadrant. The strong substrate signal needed to be subtracted can affect the value of the anisotropy field, making the calculation of $K_{\rm u}$ values from hysteresis loops error prone. Nevertheless, both techniques give similar values and show clearly the trend of K_n with film thickness. Please note that the azimuthal (in-plane) angular dependencies of the magnetic resonance field (not shown) did not reveal any magnetocrystalline cubic anisotropy.

The dimensionless Gilbert damping constant α was evaluated from the frequency dependence of the resonance peak-to-peak linewidth $\Delta H_{\rm pp}$ measured in the out-of-plane applied magnetic field for films with thickness 70, 200, and 300 nm, and measured in in-plane applied magnetic field for the two thinnest films (20 and 50 nm). The latter geometry was selected due to the overlapping background signal from the sGGG substrate with the FMR signal when recorded in the easy axis direction which hampered an accurate analysis. The frequency-dependent linewidth was fitted as follows:

$$\Delta H_{\rm pp} = \Delta H_{\rm inhom} + \frac{2}{\sqrt{3}} \frac{\alpha}{\gamma} \omega.$$

where $\Delta H_{\rm inhom}$ is a constant contribution to the linewidth caused by inhomogeneity of the sample or systematic errors and the second term is the Gilbert damping contribution. The obtained values of the Gilbert damping α are shown in Fig. 4(c). The damping constant was found to be in the range of 0.015–0.025, which is comparable with the lowest value of 0.013 so far reported in the literature²⁵ still being two orders of magnitude higher compared to YIG, mainly caused by spin-orbit coupling³⁸. No clear thickness dependence of the damping constant was observed. The inhomogeneous broadening equivalent to the zero frequency linewidth offset was found to be the lowest for TmIG films with 20 nm (7.16 kA/m \approx 90 Oe) and 300 nm (5.97 kA/m \approx 75 Oe)

thickness. For intermediate thicknesses of the TmIG films (50, 70, and 200 nm) the value of $\Delta H_{\rm inhom}$ was as large as 19.90 \pm 3.98 kA/m (250 \pm 50 Oe) which indicates more pronounced inhomogeneities of the magnetic properties within these films.

Conclusion

In this study, we have investigated the impact of layer thickness on the structural and magnetic properties of TmIG films grown epitaxially on sGGG(111) substrates. Despite the large lattice mismatch between bulk TmIG and sGGG substrates, films with a thickness up to 70 nm show an oop easy axis of magnetization due to the dominant magnetoelastic anisotropy. With increasing film thickness, we observe a strong relaxation of the induced tensile strain. As a consequence, the direction of the easy axis of magnetization changes gradually throughout the thickness series with a complete rotation towards the film plane for films thicker than 200 nm. Additionally, for all films, a Gilbert damping constant of about 0.02 was obtained, still being two orders of magnitude higher than for YIG films.

Data availability

The data that support the findings of this study are available from the corresponding author upon reasonable request.

Received: 26 July 2019; Accepted: 17 October 2019;

Published online: 25 November 2019

References

- 1. Tang, C. et al. Exquisite growth control and magnetic properties of yttrium iron garnet thin films. Appl. Phys. Lett. 108, 102403 (2016).
- Onbasli, M. C. et al. Pulsed laser deposition of epitaxial yttrium iron garnet films with low Gilbert damping and bulk-like magnetization. APL. Mat. 2, 106102 (2014).
- 3. D'Allivy Kelly, O. *et al.* Inverse spin Hall effect in nanometer-thick yttrium iron garnet/Pt system. *Appl. Phys. Lett.* **103**, 082408 (2013).
- Seifert, T. S. et al. Femtosecond formation dynamics of the spin Seebeck effect revealed by terahertz spectroscopy. Nat. Commun. 9, 2899
 (2018).
- 5. Liu, C. et al. Long-distance propagation of short-wavelength spin waves. Nat. Commun. 9, 738 (2018).
- 6. Qiu, Z. et al. Spin colossal magnetoresistance in an antiferromagnetic insulator. Nat. Mater. 17, 577-580 (2018).
- 7. Wang, H. L. et al. Large spin pumping from epitaxial Y₃Fe₅O₁, thin films to Pt and W layers. Phys. Rev. B 88, 100406(R) (2013).
- 8. Paoletti, A. Physics of Magnetic Garnets (ed. Paoletti, A) 66-75 (North-Holland Publishing Company, 1978).
- 9. Chumak, A. V., Vasyuchka, V. I., Serga, A. A. & Hillebrands, B. Magnon spintronics. Nat. Phys. 11, 453 (2015).
- 10. Mee, J. E., Pulliam, G. R., Archer, J. L. & Besser, P. J. Magnetic oxide films. IEEE Trans. Magn. MAG-5, 717 (1969).
- 11. Heinz, D. M., Besser, P. J., Owens, J. M., Mee, J. E. & Pulliam, G. R. Mobile cylindrical magnetic domains in epitaxial garnet films. *J. Appl. Phys.* 42, 1243–1251 (1971).
- 12. Kubota, M. *et al.* Systematic control of stress-induced anisotropy in pseudomorphic iron garnet thin films. *J. Magn. Magn. Mater.* 339, 63–70 (2013).
- 13. Krockenberger, Y. et al. Layer-by-layer growth and magnetic properties of Y₃Fe₅O₁₂ thin films on Gd₃Ga₅O₁₂. J. Appl. Phys. 106, 123911 (2009).
- 14. Popova, E. et al. Perpendicular magnetic anisotropy in ultrathin yttrium iron garnet films prepared by pulsed laser deposition technique. J. Vac. Sci. Technol. 19, 2567 (2001).
- 15. Popova, E. *et al.* Structure and magnetic properties of yttrium iron garnet thin films prepared by laser deposition. *J. Appl. Phys.* **90**, 1422 (2001).
- 16. Li, G. et al. Tunable perpendicular magnetic anisotropy in epitaxial Y_3 Fe $_5$ O $_{12}$ films. APL Mater. 7, 041104 (2019).
- 17. Fu, J. et al. Epitaxial growth of Y₃Fe₅O₁₂ thin films with perpendicular magnetic anisotropy. Appl. Phys. Lett. 110, 202403 (2017).
- 18. Soumah, L. et al. Ultra-low damping insulating magnetic thin films get perpendicular. Nat. Commun. 9, 3355 (2018).
- 19. Kubota, M. et al. Stress-induced perpendicular magnetization in epitaxial iron garnet thin films. App. Phys. Exp. 5, 103002 (2012).
- Kumar, N. et al. Epitaxial growth of terbium iron garnet thin films with out-of-plane axis of magnetization. Thin Solid Films 516, 7753 (2008).
- 21. Tang, C. et al. Anomalous Hall hysteresis in $Tm_3Fe_5O_{12}/Pt$ with strain-induced perpendicular magnetic anisotropy. Phys. Rev. B 94, 140403(R) (2016).
- 22. Ahmed, A. S. et al. Spin-Hall Topological Hall Effect in Highly Tunable Pt/Ferrimagnetic-Insulator Bilayers. Nano Lett. 19, 5683 (2019).
- 23. Avci, C. O. et al. Current-induced switching in a magnetic insulator. Nat. Mater. 16, 309 (2016).
- 24. Quindeau, A. et al. Tm₃Fe₅O₁₂/Pt heterostructures with perpendicular magnetic anisotropy for spintronic applications. Adv. Electron. Mater. 3, 1600376 (2017).
- 25. Wu, C. N. et al. High-quality thulium iron garnet films with tunable perpendicular magnetic anisotropy by off-axis sputtering correlation between magnetic properties and film strain. Sci. Rep. 8, 11087 (2018).
- 26. Mayer, M. SIMNRA User's Guide. Rep. IPP 9/133 (1997).
- 27. Sun, Y., Song, Y. & Wu, M. Growth and ferromagnetic resonance of yttrium iron garnet thin films on metals. *Appl. Phys. Lett.* 101, 082405 (2012).
- 28. Diamant, R. et al. The evolution of inner-shell multielectronic X-ray spectra from threshold to saturation for low- to high-Z atoms. Radiat. Phys. Chem. 75, 1434–1446 (2006).
- 29. Illig, A. J., Chantler, C. T. & Payne, A. T. Voigt profile characterization of copper Ko. J. Phys. B At. Mol. Opt. Phys. 46, 235001 (2013).
- 30. Chang, H. et al. Nanometer-thick yttrium iron garnet films with extremely low damping. IEEE Magn. Lett. 5, 6700104 (2014).
- 31. Paoletti, A. Physics of Magnetic Garnets (ed. Paoletti, A) 10 (North-Holland Publishing Company, 1978).
- 32. Wu, C. N. et al. High-quality single-crystal thulium iron garnet films with perpendicular magnetic anisotropy by off-axis sputtering. AIP Adv. 8, 055904 (2018).
- 33. Sokolov, N. S. et al. Thin yttrium iron garnet films grown by pulsed laser deposition: Crystal structure, static, and dynamic magnetic properties. J. Appl. Phys. 119, 023903 (2016).
- 34. Smit, J. & Beljers, H. G. Ferromagnetic resonance absorption in BaFe₁₂O₁₉, a highly anisotropic crystal. *Philips Res. Rev.* **10**, 113 (1955).
- 35. Suhl, H. Ferromagnetic resonance in nickel ferrite between one and two kilomegacycles. Phys. Rev. 97, 555 (1955).
- 36. Salikhov, R. et al. Magnetic anisotropy in the (Cr_{0.5}Mn_{0.5})₂GaC MAX phase. Mater. Res. Lett. 3, 156 (2015).
- 37. Farle, M. Ferromagnetic resonance of ultrathin metallic layers. Reg. Prog. Phys. 61, 755 (1998).
- 38. Hickey, M. C. & Moodera, J. S. Origin of intrinsic Gilbert damping. Phys. Rev. Lett. 102, 137601 (2009).

Acknowledgements

O.C. acknowledges financial support and scholarship received from the Bavarian Research Foundation (DOK-177–15). We thank J. Lindner (HZDR) and R. A. Gallardo (Universidad Técnica Federico Santa María, Valparaíso, Chile) for valuable discussions on FMR results.

Author contributions

O.C. and M.A. designed the experiments, analyzed the surface, structural and static magnetic properties. A.S. and K.L. analyzed the dynamic magnetic properties. All authors contributed in writing and reviewing the manuscript.

Competing interests

The authors declare no competing interests.

Additional information

Correspondence and requests for materials should be addressed to O.C.

Reprints and permissions information is available at www.nature.com/reprints.

Publisher's note Springer Nature remains neutral with regard to jurisdictional claims in published maps and institutional affiliations.

Open Access This article is licensed under a Creative Commons Attribution 4.0 International License, which permits use, sharing, adaptation, distribution and reproduction in any medium or format, as long as you give appropriate credit to the original author(s) and the source, provide a link to the Creative Commons license, and indicate if changes were made. The images or other third party material in this article are included in the article's Creative Commons license, unless indicated otherwise in a credit line to the material. If material is not included in the article's Creative Commons license and your intended use is not permitted by statutory regulation or exceeds the permitted use, you will need to obtain permission directly from the copyright holder. To view a copy of this license, visit https://creativecommons.org/licenses/by/4.0/.

© The Author(s) 2019